Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/767,768	OGAWA, HIDEHIKO	
Examiner	Art Unit	

Thomas D. Lee

OGAWA, HIDEHIKO
Art Unit
2624

SEARCHED					
Class	Subclass	Date	Examiner		
358	1.15, 402, 440	6/7/2005	TDL		
379	100.01	6/7/2005	TDL		
379	100.08	6/7/2005	TDL		
379	100.13	6/7/2005	TDL		
379	100.17	6/7/2005	TDL		
updated		9/15/2005	TDL		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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